RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2814

PATENT APPLICATION
Docket No.: 4591-346
Client Ref. No.: IH12108-US

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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|---|---|---|---|
| In re application of: | Sam Jong CHOI, et al. | | |
| Serial No.: | 10/684,343 | Examiner: | Nguyen, Dilinh P. |
| Filed: | October 10, 2003 | Group Art Unit: | 2814 |
| Confirmation No.: | 9253 | | |
| For: | SEMICONDUCTOR WAFER HAVING IDENTIFICATION INDICATION | | |
| Date: | March 12, 2007 | | |

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## AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 1106, dated December 12, 2006, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.